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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

INFORMATION DISCLOSURE STATEMENT
ACCORDING TO 37 C.F.R. §1.97(b)

APPLICANT(S): Szafraniec et al DOCKET NO: H25078
SERIAL NO.: 10/038,131 ART UNIT:
FILED: January 3, 2002 EXAMINER:
CONF. NO.
TITLE: "SYMMETRICAL DEPOLARIZED FIBER OPTIC GYROSCOPE"

Commissioner for Patents
PO Box 1450
Alexandria, Virginia 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. §1.56 and the requirements of 37 C.F.R. §1.98, Applicant respectfully requests that a citation and examination of the references identified on the attached PTO 1449 form be made during the course of examination of the above-identified application for United States Patent.

The present Information Disclosure Statement is being filed according to 37 C.F.R. §1.97(b) and before the latter occurrence of:

- (1) three months from the filing date of a national application;
- (2) three months from the date of entry of the national stage as set forth in 37 C.F.R. 1.491 in an international application; or
- (3) the mailing date of a first Office Action on the merits.

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REMARKS

The attached PTO 1449 form lists related art references for the above identified application.

EXPLANATION OF RELEVANCE


References AA, AB, and AL-AN were cited in the International Search Report. All of these references except reference AL are in English, so no further commentary on their teaching is required. An English-language abstract of reference AL has been provided, and a full translation will be produced upon request

of the Examiner.

The filing of the present Information Disclosure Statement is not to be construed as a representation that a search has been made, and is not to be construed as an admission that the information cited in the present Information Disclosure Statement is, or is considered to be, material to patentability as defined in 37 C.F.R. §1.56(b).

The above citation of related art is not a representation that such art constitutes a complete or exhaustive listing of all pertinent related art, nor that it necessarily includes the closest or most relevant art. The aforementioned citation comprises a voluntary citation of related art of which applicant and his attorney are presently aware and is not intended to serve as a substitute for the Examiner's own search.


Respectfully submitted,

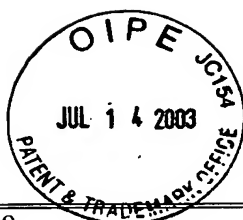
 (Reg. No. 45,877)
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CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class mail in an envelope addressed to: Commissioner for Patents, PO Box 1450, Alexandria, Virginia 22313-1450 on July 10, 2003.

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Sheet 1 of 1

Form PTO-1449					Docket No. P01,0382		Serial No. 10/038,131	
INFORMATION DISCLOSURE CITATION IN AN APPLICATION (use several sheets if necessary)					Applicant Szafraniec et al			
					Filing Date January 3, 2002		Group Art Unit	
U.S. PATENT DOCUMENTS								
Examiner's Initials		Document Number	Date	Name	Class	Subclass	Filing Date If appropriate	
	AA	5,347,354	09/13/1994	Müller et al				
	AB	5,602,642	02/11/1997	Bergh et al				
	AC							
	AD							
	AE							
	AF							
	AG							
	AH							
	AI							
	AJ							
	AK							
FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AL	42 23 740	01/20/1994	Germany			Abstract	
	AM	WO 98/00682	01/08/1998	International				
	AN	WO 00/39528	07/06/2000	International				
	AO							
	AP							
	AQ							
	AR							
	AS							
OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)								
	AT							
	AU							
	AV							
	AW							
Examiner				Date Considered				
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								

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